(19) World Intellectual Property Organization

International Bureau





(43) International Publication Date 17 July 2003 (17.07.2003)

PCT

(10) International Publication Number WO 2003/058771 A3

(51) International Patent Classification⁷:

H01S 5/183

(21) International Application Number:

PCT/US2002/039821

(22) International Filing Date:

13 December 2002 (13.12.2002)

(25) Filing Language:

English

(26) Publication Language:

English

(30) Priority Data:

10/026,020

27 December 2001 (27.12.2001) US

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(81) Designated States (national): CA, CN, JP, KR.

(84) Designated States (regional): European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE, SI, SK, TR).

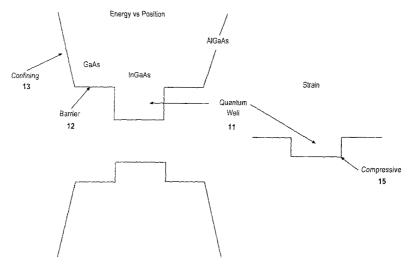
Published:

with international search report

(88) Date of publication of the international search report: 18 March 2004

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

(54) Title: VERTICAL CAVITY SURFACE EMITTING LASER INCLUDING INDIUM AND ANTIMONY IN THE ACTIVE REGION



(57) Abstract: Quantum wells and associated barrier layers can be grown to include nitrogen (N), aluminum (Al), antimony (Sb), phosphorous (P) and/or indium (In) placed within or about a typical GaAs substrate to achieve long wavelength VCSEL performance, e.g., within 1260 to 1650 nm range. In accordance with features of the present invention, a vertical cavity surface emitting laser (VCSEL), can include at least one quantum well (11) comprised of InGaAsSb; barrier layers (12) sandwiching said at least one quantum well (11); and confinement layers (13) sandwiching said barrier layers (12). A vertical cavity surface emitting laser (VCSEL), can also include at least one quantum well (11) comprised of InGaAsSbN. Barrier layers (12) can be comprised of GaAsN, GaAsP, or AlGaAs. Confinement layers (13) can be comprised of AlGaAs. Quantum wells (11) can include N. Quantum well (11) can be developed up to and including 50 Å in thickness. Quantum wells (11) can also be developed with a depth of at least 40 meV.



INTERNATIONAL SEARCH REPORT

Internationa ication No PCT/US 02/39821

A. CLASSIFICATION OF SUBJECT MATTER IPC 7 H01S5/183

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols) $IPC \ 7 \ H01S$

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ, INSPEC

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
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X	WO 00 33433 A (BRAUN WOLFGANG ;DOWD PHILIP (SG); UNIV ARIZONA (US); ZHANG YONG HA) 8 June 2000 (2000-06-08) page 19, line 20; figures 13A-13C page 11, line 26	1,2
Α	US 5 960 018 A (JEWELL JACK L ET AL) 28 September 1999 (1999-09-28) column 32 -column 34; claims 15-17; figures 8,9A/	1

Further documents are listed in the continuation of box C.	Patent family members are listed in annex.
"A" document defining the general state of the art which is not considered to be of particular relevance "E" earlier document but published on or after the international filing date "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) "O" document referring to an oral disclosure, use, exhibition or other means "P" document published prior to the international filing date but later than the priority date claimed	 *T* later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention *X* document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone *Y* document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art. *&* document member of the same patent family
Date of the actual completion of the international search	Date of mailing of the international search report
17 December 2003	02/01/2004
Name and mailing address of the ISA	Authorized officer
European Patent Office, P.B. 5818 Patentlaan 2 NL - 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo nl, Fax: (+31-70) 340-3016	Hervé, D

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PCT/US 02/39821

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